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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Masatoshi Anma

Application No.: 10/646,762

Filed: August 25, 2003

For: SEMICONDUCTOR DEVICE
HAVING A ROUGHENED
SURFACE ELECTRODE AND
METHOD OF MANUFACTURING
THE SAME

MAIL STOP AMENDMENT

Group Art Unit: 2815

Examiner: Eugene Lee

Confirmation No.: 1261

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: September 30, 2004

Sir:

This election is filed in response to the Office Action dated August 31, 2004 (Paper No. 20040823). In the Office Action, the Examiner identified two distinct inventions. The Examiner required the Applicant, under 35 U.S.C. §121, to elect a single invention for prosecution. The two inventions identified by the Examiner are:

- I) Claims 1-4, drawn to semiconductor device,
- II) Claims 5-10, drawn to method of making a semiconductor device.

Pursuant to the Examiner's requirement, the Applicant elects Group I, claims 1-4. It is understood that claims 5-10 will be withdrawn from prosecution. Applicant reserves the right to file divisional applications.

An earlier examination and favorable action on claims 1-4 are respectfully requested.

In the event this paper is not considered to be timely filed, Applicants hereby petition for an appropriate extension of time. The Commissioner is authorized to charge payment for any additional fees which may be required with respect to this paper to our Deposit Account No. 02-4800.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

Date: September 30, 2004

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